March 31 2003

TSMC00-488

APR 0 7 2003

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

131 ATTN: GROUP ART UNIT 2823 W. D. COLEMAN

FR: Stephen B. Ackerman Reg. No. 37761

28 Davis Avenue Poughkeepsie NY 12603

Subject:

Serial No. 09/863,223

05/24/01

"Prevention of post CMP defects in Cu FSG process"

C-S Liu and S-L Shue

Grp. Art Unit: 2823

W. D. Coleman

TECHNOLOGY CENTRAL OF THE PROPERTY OF THE PROP

RESPONSE TO PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated December 31 2002, in the above identified application for patent, please enter the following amendments and consider the following remarks.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on March 31 2003.

Rephen & Acherman

Name

Signature/Date